

Confirmation No.9703

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Deixler	Examiner:	Pompey, Ron Everett
Serial No.:	10/587661	Group Art Unit:	2812
Filed:	10/30/2007	Docket No.:	US030427US2
Title:	METHOD OF FABRICATING A SiGe SEMICONDUCTOR STRUCTURE		

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No. 65913

Dear Sir:

This communication is in reply to the Office Action dated November 16, 2009 in which a restriction/election requirement was presented. In response thereto, Applicant provisionally elects Species 1 and Claims 1 -12 with traverse.

A complete listing of the Claims follows on page 2.

Remarks begin on page 4.